



RCE/1763
702
PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

February 6, 2003

In re the Application of

Kazuo ICHIKAWA et al.

Application No.: 09/670,877

Group Art Unit: 1763

Examiner: R. Zervigon

Filed: September 27, 2000

Docket No.: 107469

For: CVD SUBSTRATE AND CLEANING METHOD

**LARGE ENTITY PETITION FOR 1st - 3rd EXTENSION
OF TIME UNDER 37 C.F.R. §1.136(a) AND
TRANSMITTAL OF FEE UNDER 37 C.F.R. §1.17**

RECEIVED
FEB 10 2003
TC 1700

11
2/11/03
MW

Director of the U.S. Patent and Trademark Office
Washington, D.C. 20231

Sir:

Transmitted herewith is a response to the outstanding Official Action in the above-identified patent application. The shortened statutory period having expired November 6, 2003, an extension of time for a period of three months is hereby requested. (Payment of \$110 for a one month extension was already made.)

Attached hereto is our Check No. 138756 in the amount of \$820 in payment for:

Extension fee for response within first month pursuant to §1.136(a) (\$110.00)
 Extension fee for response within second month pursuant to §1.136(a) (\$410.00)
 Extension fee for response within third month pursuant to §1.136(a) (\$930.00)

The Director is hereby authorized to charge any additional fee or credit any overpayment associated with this communication to Deposit Account No. 15-0461. Two copies of this petition are enclosed.

Respectfully submitted,

James A. Oliff
Registration No. 27,075

Stephen Tu
Registration No. 52,304

02/07/2003 CNGUYEN 00000012 09670877

01 FC:1253

820.00 OP

JAO:SXT/amw

OLIFF & BERRIDGE, PLC
P.O. Box 19928
Alexandria, Virginia 22320
Telephone: (703) 836-6400

DEPOSIT ACCOUNT USE
AUTHORIZATION
Please grant any extension
necessary for entry;
Charge any fee due to our
Deposit Account No. 15-0461